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7/15/13

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiroshi SONOBE

Group Art Unit: 2133

Serial No.: 09/557,088

Examiner: Matthew C. Dooley

Filed: April 21, 2000

For: SEMICONDUCTOR INSPECTION METHOD

AMENDMENT

RECEIVED

JUL 14 2003

Technology Center 2100

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed April 11, 2003,
please amend the above-identified application as follows:

PLEASE ACCEPT THIS AS
AUTHORIZATION TO DEBIT
OR CREDIT FEES TO
DEP. ACCT. 16-0331
PARKHURST & WENDEL